

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Terunao HANAOKA and Kenji WADA

Application No.: Divisional of Application No.  
09/870,710 filed June 1, 2001

Filed: February 2, 2004

Docket No.: 109690.02

For: SEMICONDUCTOR DEVICE, METHOD OF FABRICATING THE SAME, STACK-  
TYPE SEMICONDUCTOR DEVICE, CIRCUIT BOARD AND ELECTRONIC  
INSTRUMENT

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.

- ☒ 2. The references were cited by or submitted to the Office in parent application No. 09/870,710, filed June 1, 2001, which is relied upon for an earlier filing date under 35 U.S.C. §120. Thus, copies of these references are not attached. 37 CFR §1.98(d).

Respectfully submitted,



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<p>DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461</p>
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Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 109690.02		APPLICATION NO. Divisional of Application No. 09/870,710	
INFORMATION DISCLOSURE STATEMENT  (Use several sheets if necessary)				APPLICANT(S) Terunao HANAOKA and Kenji WADA			
				FILING DATE February 2, 2004		GROUP	

  

U.S. PATENT DOCUMENTS						
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS
		4,696,885	09/1987	Vijan		
		5,949,140	09/1999	Nishi et al.		
		6,404,061	06/2002	Hikita et al.		
		6,225,651 - B1	05/2001	Billon	257	200
		6,222,276	04/2001	Bertin et al.	257	778
		6,150,188 - A	11/2000	Geusic et al.	438	31
		5,926,951 - A	07/1999	Khandros et al.	29	843
		5,548,118 - A	08/1996	Walker	250	332
		5,229,647 - A	07/1993	Gnadinger	257	783
		4,984,358 - A	01/1991	Nelson	438	109

  

FOREIGN PATENT DOCUMENTS						
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS
		JP A5-206286	08/1993	Japan		
		JP A 8-83881	03/1996	Japan		
		JP A 10-223833	08/1998	Japan		
		JP-52065666-A	05/1997	Japan		
		9-321175	12/1997	Japan		

  

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)						

  

EXAMINER	DATE CONSIDERED
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Examiner:	Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.
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Date: February 2, 2004